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Fluorinated porous silicon as sensor material for environmentally toxic gases: a first-principles study

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By using Density Functional Theory, the effect of adsorbed gas molecules on the electronic properties of fluorine passivated porous silicon (pSi) is investigated. A silicon nanopore is created by removing columns of atoms along the [001] crystallographic axis from a supercell of the bulk Si crystal. The Si dangling bonds of the generated pore are saturated with fluorine atoms except for the sites where gas molecules of NO, NO₂ and SO₂ are adsorbed. The adsorption energies, electronic densities of states and band structures of the different complexes formed by the nanopore and the adsorbed molecules are calculated and compared with previously reported results obtained for hydrogen-passivated pSi. The energy band gaps of the pSi-molecule complexes depend on the adsorbed species, opening the possibility of gas molecule recognition. The molecule adsorption energy is stronger for NO₂. The understanding of molecule adsorption on silicon nanopores could lead to the development of novel sensing devices of environmentally hazardous gases.

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Introduction

According to the Health Effects Institute (HEI), 90% of people around the world are breathing polluted air containing toxic gas molecules such as NO_x and SO_x, which causes around 6.1 million premature deaths per year.¹ Also, the presence of these gases causes the ozone layer destruction (contributing to the greenhouse effect), acid rain, and the acidification of rivers and lakes.^{2,3} Therefore, the control of air pollution requires the study, design, and fabrication of devices and materials capable of detecting those polluting agents.

During decades, materials such as electronic ceramics, metal oxides, semiconductors and conducting polymers have been studied to address their potential as toxic gas detectors.^{4–6} Particularly, bulk and nanoribbons of α -MoO₃ and porous silicon oxycarbide have high sensitivity for the detection of harmful gases such as NO₂.^{7–9} Moreover, nanostructured materials, such as silicene nanoribbons¹⁰ and graphene,^{11–13} have been proposed as potential detectors of other toxic gases, for example SO₂, NH₃ and CO. Silicon nanostructures, such as nanoporous structures and nanowires, have also gotten positive results in this task.^{14–16} Since its report of fabrication in 1990 by anodization in hydrofluoric acid

(HF) of crystalline silicon substrates,^{17–19} porous silicon has generated great interest in the scientific community. Fast preparation, tuneable optical and electronic properties, large inner surface area, surface reactivity, good stability and full compatibility with modern electronic technology are some of the advantageous properties of pSi. In particular, a large surface area is required for a good molecule adsorption and pSi etched on p-type Si(100) provides a surface area of $\sim 200 \text{ m}^2 \text{ cm}^{-3}$ and a site density of 6.8×10^{14} sites per cm^2 .^{20–22} Additionally, it has been proven that pSi can operate in a voltage range of 1–10 mV with a sensitivity range of 10–100 ppm.²³ This allows the use of pSi in sensing electronic devices, ranging from the detection of several chemical agents to the identification of DNA chains and proteins.^{15,24–26} Moreover, several experimental studies have been done to prove that pSi, grown in [100] Si wafers, can be an active gas sensing device.^{5,27–30}

In a similar way, surface chemistry has been proved to modify the electronic structures and optical behaviour of semiconductors.³¹ Hydrogen passivation causes a transition from metallic to semiconducting behaviour in Si nanowires^{32,33} and band gap changes in another Si nanostructures.^{34–37} Previous studies show that single-bonded atoms on Si surfaces, for example, Cl and F, may lightly diminish the energy bandgap.^{38–40} The same occurs with double-bonded atoms, such as N and O, but the bandgap decrement is larger in comparison with single-bonded atoms.^{41,42} However, it has been experimentally observed that the H-passivated pSi surface is rapidly oxidized in

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air,^{43,44} which leads the surface to irreversible modification and, consequently, a decrease in the sensitivity of this material to molecules such as NO₂.⁴⁵ Therefore, the surface fluorination of pSi is a key ingredient in this work, considering that the presence of fluorine atoms on the Si surface could inhibit the formation of silicon oxide⁴⁶ and make the dissociation of adsorbed oxygen-containing molecules less likely. Even though the interactions between silicon surfaces and fluorine-containing molecules are complicated, the fluorination process of Si surfaces has been extensively studied. Wu and Carter report that F atoms only saturate the Si-dangling bonds.⁴⁷ Also, Hoshino and Nishioka indicate that the development of F-passivated silicon surfaces is possible after a chemical reaction of hydrogen fluoride (HF) with H-passivated silicon surfaces.^{48,49} Otherwise, the fluorination of H-passivated silicon surfaces has been recently studied using different F-containing molecules.⁵⁰ Fluorine-passivation is a feasible and advantageous way of tuning the electronic properties of pSi.

In a previous work, the adsorption of hazardous gas molecules, such as CO, NO, NO₂ and SO₂, on pSi passivated with hydrogen (pSi+H) was studied.¹⁵ Concerning to the fluorine-passivated pSi (pSi+F), there is not, to the best of our knowledge, a theoretical investigation of the adsorption properties of this passivation. For this reason, in this work, we study the effects of fluorine surface passivation of pSi on the adsorption of hazardous gas molecules such as NO₂, SO₂, and NO, and compare these results with those previously reported for pSi+H. To this end, the electronic band structures and energetic stabilities of the formed molecule-nanopore complexes, together with the molecule adsorption energies, charge excesses and desorption times, are analyzed. The results obtained are related to the potential application of pSi+F as chemical sensors.

Computational details and model

Density-Functional-Theory (DFT)^{51,52} calculations were carried out using the Perdew–Burke–Ernzerhof (PBE) exchange–correlation

functional within the generalized-gradient approximation (GGA),⁵³ with double- ζ polarized basis sets^{54,55} and norm-conserving Troullier–Martins pseudopotentials⁵⁶ in their fully non-local form⁵⁷ as implemented in the SIESTA code.⁵⁸ For numerical integrations, a real-space grid defined by an energy cutoff of 160 Ry was considered. Geometry optimization was done through a conjugate gradient algorithm until the Hellmann–Feynman forces were less than 0.04 eV Å⁻¹, with an average maximum value of 0.037 eV Å⁻¹. The average energy change per atom was 2.79×10^{-6} eV, the maximum atomic displacement allowed in the optimization process was 0.105 Å, and the maximum and minimum obtained values for the atomic displacements were 2.52×10^{-3} Å and 9.56×10^{-5} Å, for pSi+H, respectively. Likewise, for pSi+F, the corresponding values were 2.08×10^{-3} Å and 4.37×10^{-5} Å.

Following the Monkhorst–Pack scheme, the first Brillouin zone of the studied systems was sampled with a grid of $2 \times 2 \times 2$ *k*-points.⁵⁹ The Voronoi electronic population analysis was used to obtain the electronic charge transfer between gas molecules and the passivated pSi.⁶⁰

A porous silicon supercell with 38.28% porosity is obtained by removing a column of atoms along the [001] direction of a bulk Si supercell, leading to {110} internal pore surfaces. The bulk crystalline Si supercell is formed by $4 \times 4 \times 4$ cubic unit cells (8 atoms per unit cell). The resulting porous supercell, with periodic boundary conditions along the three spatial directions, has cell parameters $a = b = c = 22.09$ Å.

The dangling bonds of the exposed surfaces were saturated with fluorine atoms before the structural optimization was carried out, to prevent their reconstruction.

After the structural optimization of the fully passivated nanopores, one passivating atom was detached from a {110} facet to generate a Si dangling bond, and then this structure was structurally relaxed again. Fig. 1 shows the optimized passivated pSi structures together with the equilibrium configurations of the adsorbed molecules (NO, NO₂ and SO₂). The dangling bond

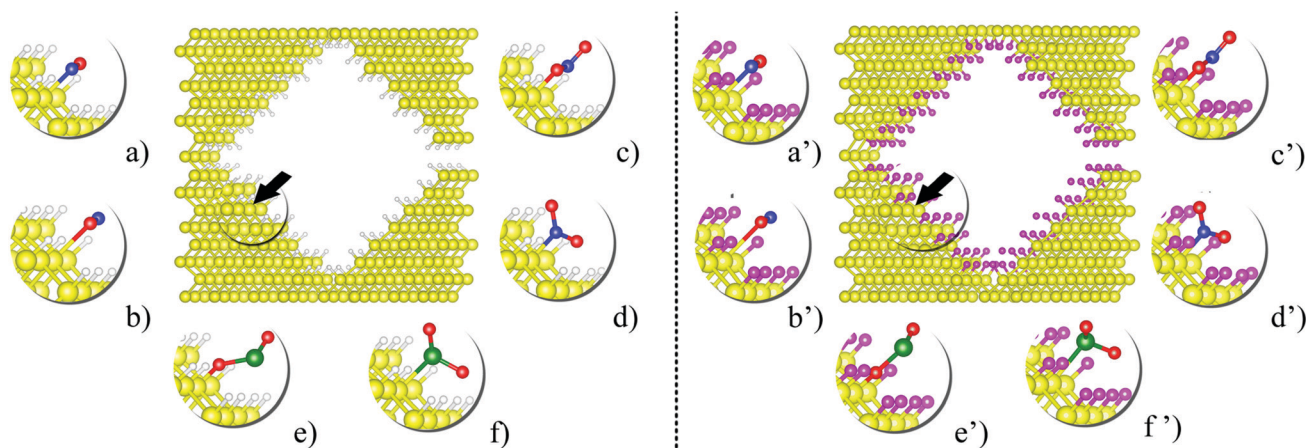


Fig. 1 Optimized structures of pSi with H- (left panel) and F-passivation (right panel); together with the equilibrium configurations of (a and a') NO(N), (b and b') NO(O), (c and c') NO₂(O), (d and d') NO₂(N), (e and e') SO₂(S), (f and f') and SO₂(O) adsorbed molecules. The symbol in parenthesis indicates which atom of the adsorbed molecule is bonded to the pSi dangling bond. Yellow, white, magenta, green, blue and red spheres represent Si, H, F, S, N and O atoms, respectively.



sites (black arrows on Fig. 1) were used as adsorption sites for the molecules. For comparison purposes the same process was performed with H passivation, considering, as stated before, that the potential adsorption of these molecules would eventually lead to an oxidation of the pSi surface and a loss of sensing capabilities.

Results and discussion

In this section, we analyse the electronic band structure of F-passivated pSi, the HOMO–LUMO gap, the charge transfer from the molecule to the pSi, the molecule adsorption energy, the desorption time and the bond distance between the molecule and pSi.

Hydrogen- and fluorine-passivated porous silicon

Fig. 2 and 3 show the charge density difference (CCD), the electronic band structure and PDOS of the structurally relaxed pSi+H and pSi+F, respectively.

The orange (gray) isosurfaces in Fig. 2b and 3b illustrate the gain (loss) of electronic charge in comparison with the ground-state charge density of the isolated atoms, for the pSi systems. They are given by:

$$\delta\rho(\vec{r}) = \rho_X(\vec{r}) - \rho_M(\vec{r}), \quad (1)$$

where $\rho_X(r)$ is the charge density of the pSi with X passivation obtained from the DFT self-consistent calculations, while $\rho_M(r)$ is the electronic charge density resulting from the sum of the ground-state charge densities of each atom. Both terms in eqn (1) are calculated with each atom of the system situated at the position of the optimized structure.

The Voronoi charge transfer from passivating atoms to Si atoms is markedly different between the F and H cases, having

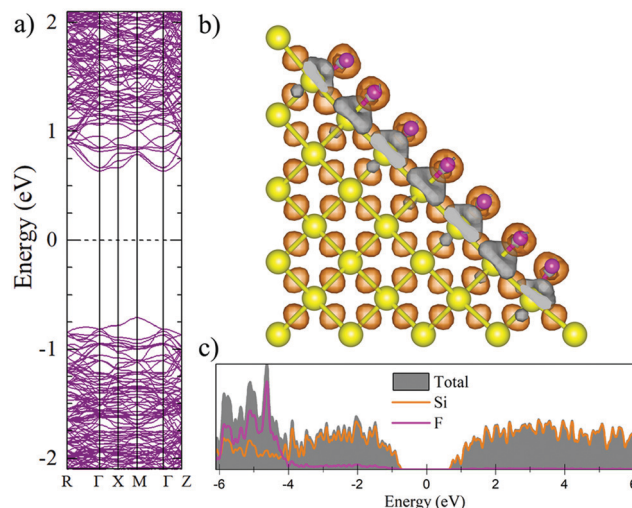


Fig. 3 Electronic band structure (a), charge density difference (b) and partial electronic densities of states (c) of the fluorinated pSi after geometrical optimization. Orange (gray) isosurfaces denote gain (loss) of electronic charge in comparison with the ground-state charge density of the isolated atoms, for F-passivated pSi.

values of $-0.1126 |e|$ and $-0.0435 |e|$, respectively. In case of F-passivation (Fig. 3b), we find a prominent redistribution of charge around the F atoms and on the Si surface (gray isosurface) in comparison with the H-passivated system (Fig. 2b). Also, we can see a decrement in the bandgap energy from 1.48 eV for H-passivation to 1.34 eV for F-passivation (Fig. 2a and 3a). This difference can be better understood with the partial density of species (PDOS) representation shown in Fig. 2c and 3c. The bonding energy between a surface Si and an H atom is 4.6 eV, indicating that the Si–H bonds are stable.⁶¹ The difference in electronegativities between H (2.2) and Si (1.9), indicates that this is a polar covalent bond, which is corroborated by both the charge excess on the H atoms and the charge density isosurfaces, where the higher charge density values are predominantly found close to the H atoms. There are small grey lobes around the Si surface atoms, which indicates that part of its charge gets transferred to the H as expected. Comparatively the F has similar characteristics, however, due to the much higher electronegativity of F, the bond became almost ionic in nature, and the surface silicon atoms undergo a greater charge loss, thus reflected in a narrower band gap due to the increase of available states of the surface Si atoms.

Adsorption and desorption properties

Fig. 4 shows the adsorption energy (E_A) and the bond distance (β) between the molecules and the passivated pSi. For each molecule, we consider that bonding with pSi may be possible through each of their constituent elements, for example, in the case of NO_2 , we consider the cases in which N–Si or O–Si bonds may be created. The adsorption energy (E_A) of a molecule adsorbed on the pSi is given by:¹⁴

$$E_A = E_{\text{Mol}} + E_{\text{X+DB}} - E_{\text{X+DB+Mol}} + E_{\text{BSSE}}, \quad (2)$$

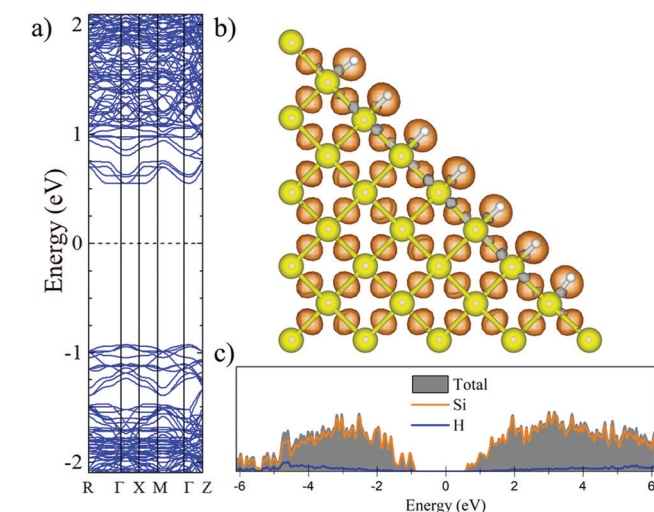


Fig. 2 Electronic band structure (a), charge density difference (b) and PDOS (c) of the totally hydrogenated pSi after geometrical optimization. Orange (gray) isosurfaces denote gain (loss) of electronic charge in comparison with the ground-state charge density of the isolated atoms, for H-passivated pSi.



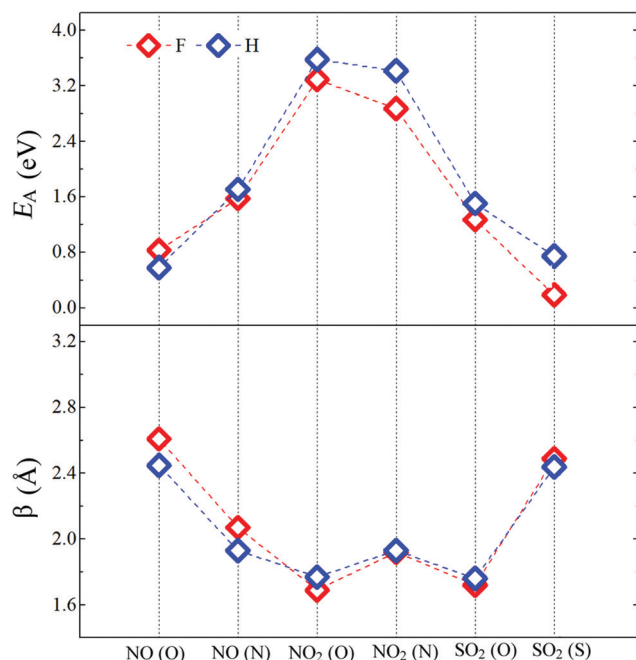


Fig. 4 Adsorption energies (E_A) and bond distances (β) between molecules and pSi for both kinds of passivation. Red and blue symbols represent pSi+F and pSi+H, respectively.

where E_{Mol} , $E_{\text{X+DB}}$, and $E_{\text{X+DB+Mol}}$ are the energies of the molecule, the X-passivated nanopore (X = H or F) with a Si dangling bond (DB) and the optimized complex formed by the X-passivated pSi with a gas molecule adsorbed on a DB, respectively. We have included the basis set superposition error correction (E_{BSSE}), given by the difference between the energies obtained with the individual and the combined basis-set functions of the pSi and the adsorbed molecule.⁶² A stronger adsorption of the molecule on the nanopore is indicated by a higher, or more positive, value of E_A .

After comparing the results of the adsorption energies and bond distances, it can be seen that the numerical results for H and F passivation follow each other very closely, indicating that the chemical composition on the superficial layer does not affect in a significant way the adsorption strength of the molecules. The larger E_A among all the studied cases corresponds to the NO_2 molecule. For H- and F-passivation schemes, these energies are 3.58 eV and 3.29 eV, respectively, when the bonding occurs through the O atom; and 3.41 and 2.87 eV, respectively, when the N atom is bonded to the pSi surface. Also, this molecule has the smallest bond distance between its O atom and the Si surface atom, being 1.77 Å for H-passivation and 1.69 Å for F-passivation; which is close to reported experimental Si–O bond length of 1.63 Å.^{63,64} For the Si–N bond, we found almost the same distance for pSi+H and pSi+F, being 1.93 and 1.92 Å, respectively. These distances are shorter than those found for Si–N bonds of 2.27 Å.⁶⁵ On the other hand, the lowest E_A corresponds to the NO (O) molecule on the pSi+H and the SO_2 (S) molecule on the pSi+F, with E_A of 0.58 eV and 0.19 eV, and bond distances of 2.45 and 2.49 Å, respectively.

These results seem to indicate that the NO_2 and SO_2 molecules, when interacting through their O atoms, having the strongest binding energy, have a strong chemical interaction with the surface of the H- or F-passivated pSi.

For a NO molecule adsorbed on pSi with H (F) passivation, the corresponding adsorption energies are 0.58 eV (0.83 eV) and 1.71 eV (1.57 eV) when the bonding occurs through O and N, respectively. The NO-pSi distances are 2.45 Å (2.61 Å) when the bonding occurs through O, and 1.93 Å (2.07 Å) when the bonding occurs through N, exceeding the experimental reported results in both cases. For the H-passivated case, the adsorption energy of SO_2 (S) (0.74 eV) is larger than that of the F-passivated case, but they have a similar bond distance of 2.44 Å. For SO_2 (O), the adsorption energies and the bond distances are 1.50 eV, 1.26 eV and 1.76 Å, 1.72 Å, for the H- and F-passivated pSi, respectively. These results show that the NO_2 has a tendency to get tightly bonded to the pSi surface, which hints that pSi may not be suitable for its detection since the adsorption of NO_2 could lead to a fundamental change on the surface chemistry of the pSi which may not be able to be reversed.

For a better understanding, the adsorption reaction could be described as $\text{pSi}_{(n-1)} + \text{X} \rightarrow \text{pSi}_{(n-1)}\text{X}$, where pSi refers to pSi+H or pSi+F, n is the maximum number of F or H surface passivating atoms on the pSi surface and $(n - 1)$ denotes the existence of at least one dangling bond formed during the pSi synthesis. X refers to the adsorbed molecule (X = NO, NO_2 or SO_2) which can be adsorbed through both of its constituent atoms.

The van't Hoff–Arrhenius expression^{66,67} and the transition state theory give us the possibility to evaluate the recovery time of pSi+F and pSi+H after the molecule adsorption using the following equation:^{68,69}

$$t = A^{-1} e^{\left(\frac{E_A}{k_B T}\right)} \quad (3)$$

where A denotes the frequency of oscillation of the adsorbed molecule. E_A is the adsorption energy; k_B is the Boltzmann's constant and T is the test temperature. Notice that, at a specific temperature, a smaller value of E_A results in lower desorption time. Based on this, we compared the desorption time of the studied gas molecules adsorbed on pSi+F and pSi+H. The A value was chosen to be 1012 s^{-1} as estimated in other studies.^{66–69} Desorption times were calculated at 273, 298 and 473 K, see Fig. 5. As expected, desorption times depend on the adsorption energy of the molecule which in turn slightly depends on the pSi surface passivation. At the temperatures tested, the NO_2 molecules will practically never desorb. All other results for desorption time are shown in Table 1. Both the adsorption energies and desorption time indicate that these structures could be suitable for detection of NO and SO_2 , while for NO_2 the strong adsorption energy and high desorption time indicates that the molecule will not be able to desorb therefore making its detection less useful, however it could have potential for trapping these hazardous molecules.



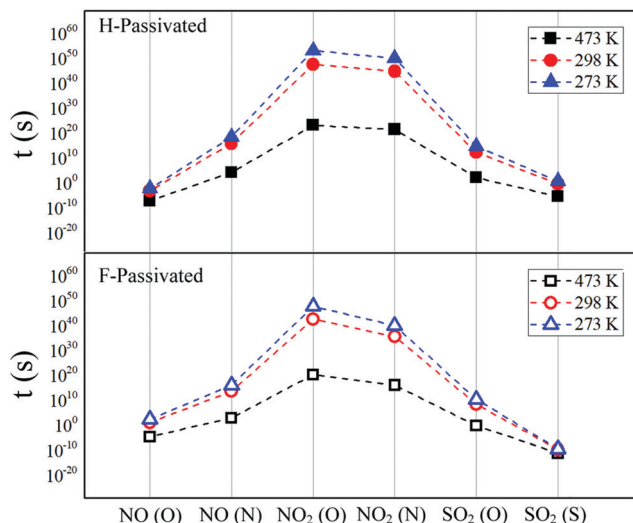


Fig. 5 Desorption times (t) of molecules from pSi+H (top panel, solid symbols) and pSi+F (bottom panel, open symbols). Triangle, circles and square symbols represent the different tested temperatures: 273, 298, and 473 K, respectively.

Relative stability and charge transfer

The relative energetic stability of the nanostructures with an adsorbed molecule is approximated by the Gibbs free energy of formation (δG):¹⁶

$$\delta G = -E_C + \sum \chi_M \mu_M, \quad (4)$$

where E_C and μ_M are the cohesive energies per atom of the nanostructure and the chemical species M ($M = \text{Si, H, F, C, N, S, and O}$) in their natural form, respectively, calculated with the same level of theory described above. χ_M is the molar fraction of atomic species M , satisfying $\sum_M \chi_M = 1$. E_C can be calculated as:

$$E_C = \frac{\left(\sum_M N_M E_M - E_T \right)}{N_T}, \quad (5)$$

where E_M and E_T are the total energies of an atom of type M and the complex formed by the adsorbed molecule and the nanopore, respectively. N_M and N_T are the number of atoms of species M and the total number of atoms in the system's supercell, respectively. More negative values of δG indicate chemical stability and exothermic formation processes. The results

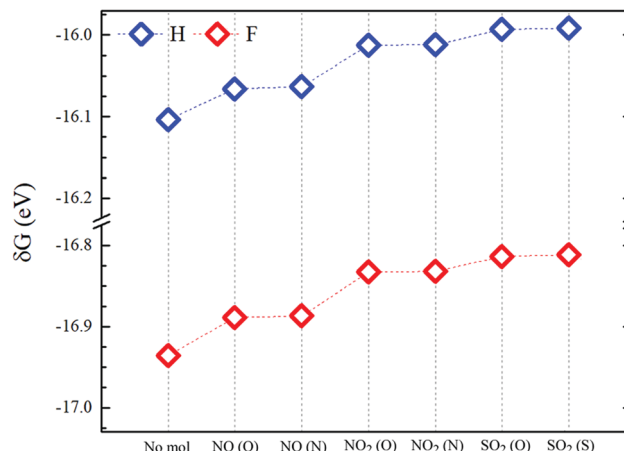


Fig. 6 Formation energies (δG) of molecule-pSi complexes for fluorine (red symbols) and hydrogen (blue symbols) passivation. "No mol" denotes the passivated pSi without adsorbed molecules.

for all the molecules and configurations, plus the fully passivated case without molecules (called "No mol"), is showed in Fig. 6, along the hypothetical cases of adsorption on H-passivated pSi. Observe that both formation energies are negative, thus indicating that both structures are stable, which is expected due to the high number of Si atoms that conform the pSi framework; however, the fluorinated cases are substantially more stable, coinciding with the reported results that fluorination diminishes the reactivity of Si surfaces in comparison to hydrogen passivation. Although the inclusion of the molecules on the pore surface rises the formation energy, these changes are not drastic, hence the adsorption is possible. The difference between δG for both passivation schemes is consistent around 0.85 eV, and the following trend is observed for δG : No mol < NO < NO₂ < SO₂, for both passivation schemes, regardless of the atom of the molecule bonded to the pSi.

In this way, to better understand the interaction between pSi and the toxic molecules, we calculated the molecule charge excess by using the Voronoi population analysis. Fig. 7 shows the charge excess on the adsorbed molecules, where positive values indicate that the molecule transferred electrons (negative charge) to the passivated pSi. This is the case of NO in its two adsorption configurations on the pSi+F. Likewise, negative values of the charge transfer indicate an electronic charge transfer from the pSi to the molecule, as occurs for the rest

Table 1 Molecule desorption time in seconds

	Test temperature					
	273 K		298 K		473 K	
	pSi+H	pSi+F	pSi+H	pSi+F	pSi+H	pSi+F
NO (O)	2.22×10^2	5.70×10^{-3}	1.15×10^1	7.14×10^{-4}	2.59×10^{-5}	7.88×10^{-8}
NO (N)	1.17×10^{16}	3.84×10^{18}	4.27×10^{13}	8.61×10^{15}	8.62×10^2	2.06×10^4
NO ₂ (O)	5.38×10^{47}	1.19×10^{53}	4.33×10^{42}	3.42×10^{47}	1.96×10^{20}	1.67×10^{23}
NO ₂ (N)	1.12×10^{40}	1.09×10^{50}	3.98×10^{35}	5.59×10^{44}	1.21×10^{16}	3.60×10^{21}
SO ₂ (O)	2.68×10^{10}	5.85×10^{14}	2.90×10^8	2.74×10^{12}	6.96×10^{-1}	1.67×10^2
SO ₂ (S)	3.52×10^{-10}	6.45×10^0	1.78×10^{-10}	4.48×10^{-1}	8.80×10^{-12}	3.72×10^{-6}



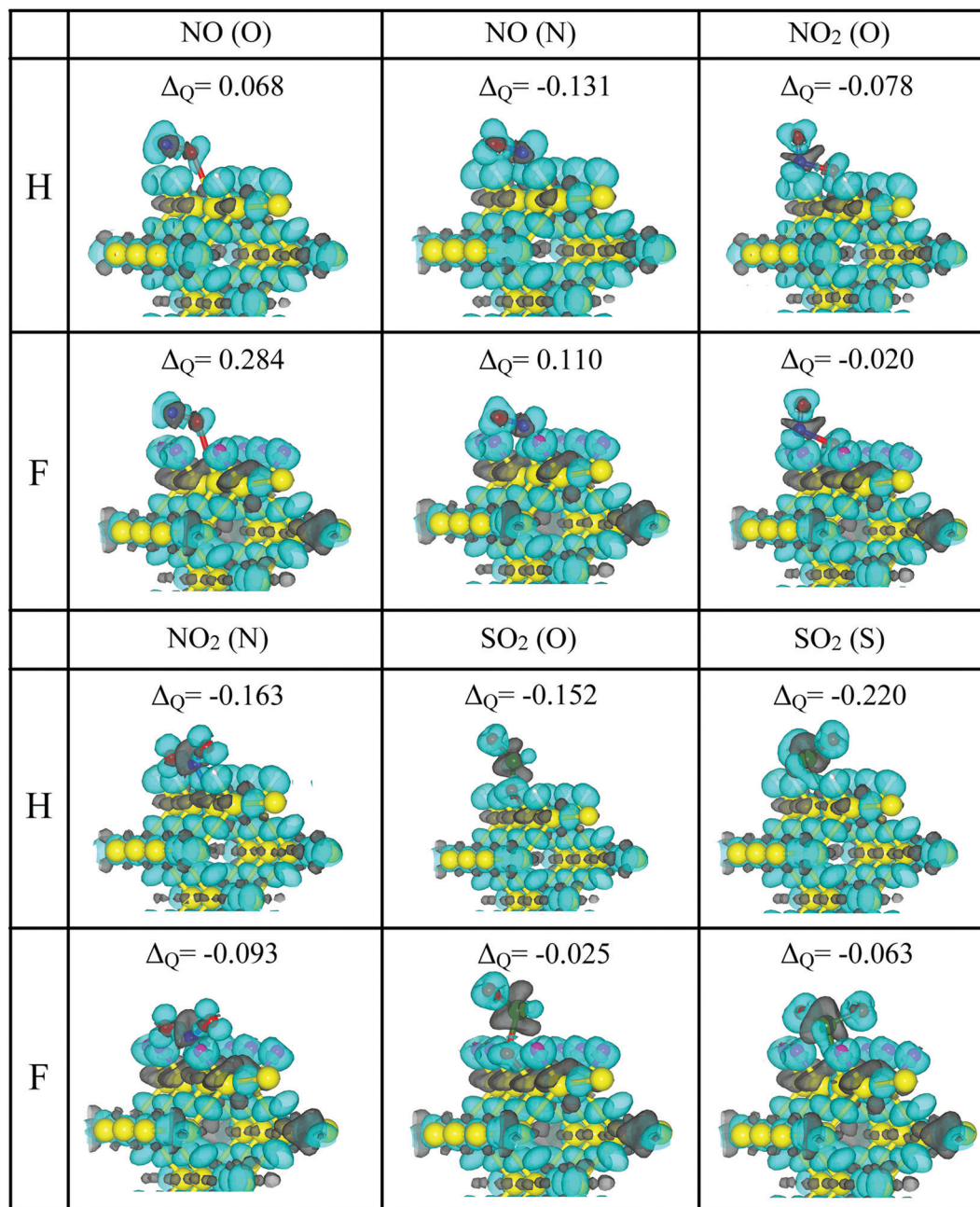


Fig. 7 Molecule charge excess (ΔQ) and CDD isosurface plots of NO, NO₂ and SO₂ molecules adsorbed on F- (magenta) and H-passivated (blue) pSi. The pSi+F and pSi+H cases are indicated in the left column as F and H, respectively. The isosurfaces have a value of 0.06 electron per Å³. Cyan (gray) isosurfaces denote gain (loss) of electronic charge in comparison with the ground-state charge density of the isolated atoms, for H or F-passivated pSi systems.

of the cases. These results are complemented by the three-dimensional isosurface plots of CDD (eqn (1)). In the cases of NO₂ and SO₂, there are small grey lobes around the Si dangling bond, which indicates that pSi transfers electronic charge to the molecules. On the other hand, these small gray lobes are not observed on the NO cases, where the molecule is losing electronic charge. Also, when NO₂ is bonded through an O atom, there is a gain of charge density around the Si–O bond, and an extended loss of charge between that O atom and the N one, for both passivation cases, indicating the formation of a

Si–O covalent bond, confirmed by the large magnitude of the adsorption energy found in this case (see Fig. 4). Changes of the former electrical resistivity of pSi after the adsorption of toxic molecules are expected due to these charge transfers, which could be measured by experiments.⁷

Electronic properties

Fig. 8 shows the electronic band structures and the partial densities of the with the adsorbed molecules. Upon NO adsorption, two impurity levels, one above and the other below the



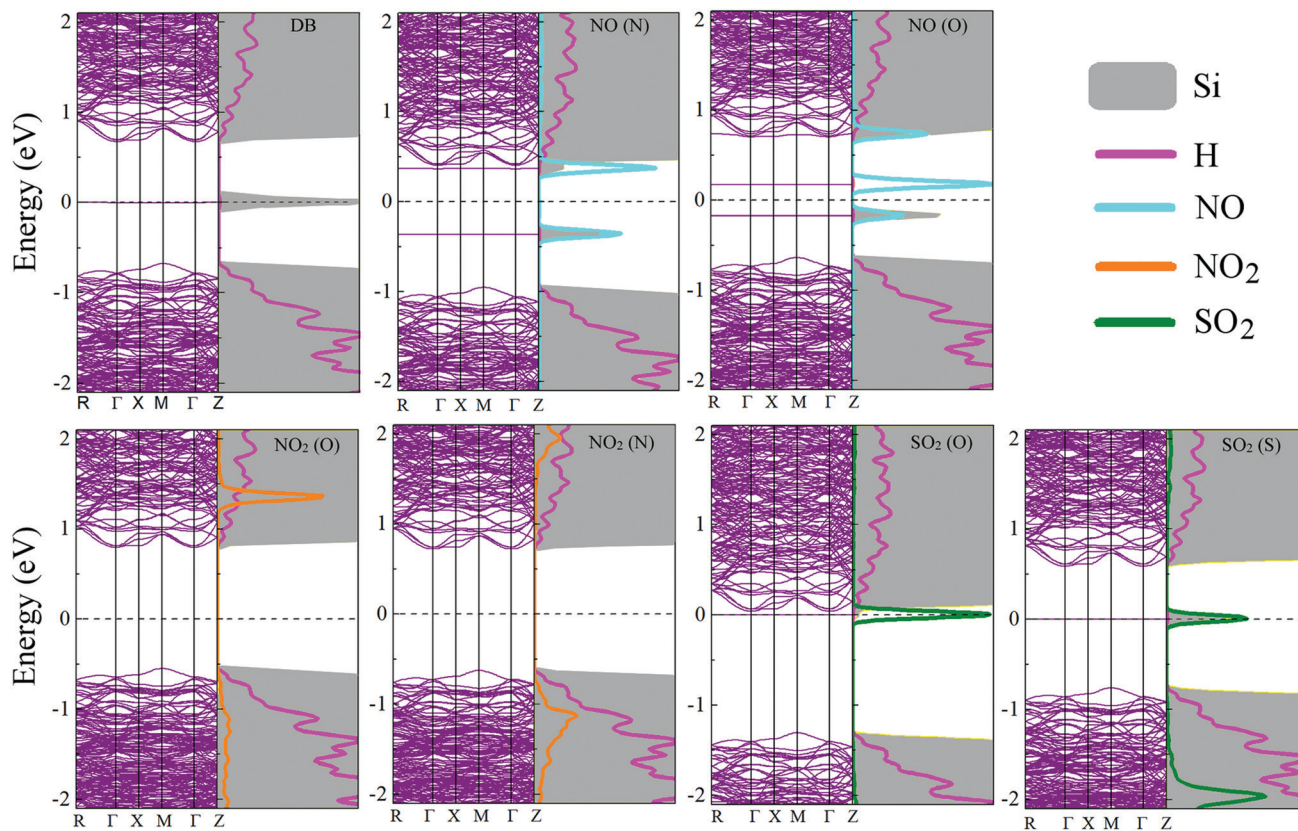


Fig. 8 Electronic band structure and partial density of states for the studied molecule-pSi+F systems. Fermi level is indicated with a dashed line at 0 eV.

Fermi level, appear with energy differences that lead to band gaps of 0.340 eV for NO (O) and 1.344 eV for NO (N). These flat states suggest that there are highly localized orbitals around the molecule. On the adsorption of NO₂, no impurity states appear within the band gap, but there is a contribution from the molecule to the electronic states inside the conduction and the valence bands, this could be understood in terms of the stronger adsorption of the NO₂ onto the pSi surface, which leads to less localized states compared to the other molecules that have weaker bonds to the pore, *i.e.*, lower adsorption energies, and in consequence, quicker desorption times than the NO₂ cases (see Fig. 5). In this case, the value of the band gap is equal to that of the fully fluorinated case (1.47 eV) indicating that a strong bond is formed between the Si and the constituent atoms of the molecule, which is similar to the F passivation leading to a band gap without defect states. For both SO₂ adsorption configurations, a localized state emerges within the former pSi+F band gap, thus modifying its value. These modified band gaps are 0.037 eV for SO₂ (O) and 0.585 eV for SO₂ (S). In the case of SO₂ (O) adsorbed on pSi+F, the Fermi level shifts towards the conduction band, similar to a n-type doping effect, which could facilitate the electronic detection of this molecule.

Fig. 9 shows the isosurface plots of the eigenfunctions of the valence band maximum (HOMO) and conduction band minimum (LUMO) energy eigenvalues, together with the magnitudes of the bandgaps of the studied systems. For both NO adsorption cases

showed in Fig. 9, observe that the HOMO and LUMO isosurfaces are concentrated around the molecule, which corroborates that the flat states showed in Fig. 8 come mostly from the NO molecule. On the other hand, the HOMO and LUMO isosurfaces for the NO₂ adsorption cases indicate that the molecule does not contribute to the corresponding electronic states since these isosurfaces are concentrated around the Si-Si bonds, in agreement with the partial density of states analysis (Fig. 8). Finally, the isosurfaces corresponding to both SO₂ adsorption cases show that the HOMOs are concentrated around the molecule, and the LUMOs around the Si atoms, respectively indicating that the HOMO flat states come from the molecule, and the LUMO states come mostly from the Si atoms. Summarizing, for the cases where impurity states are found within the former pSi band gap, HOMO and LUMO isosurface plots confirm that these flat states come mostly from the adsorbed molecules, in agreement with Fig. 8. Some of the studied cases could be interesting for the design of optical sensors, where the pSi optical band gap change, upon toxic molecule adsorption, could be detected through the corresponding change in the wavelength of the adsorbed radiation.

Conclusions

The adsorption of the hazardous gas molecules NO, NO₂ and SO₂, on fluorine-passivated porous silicon has been theoretically



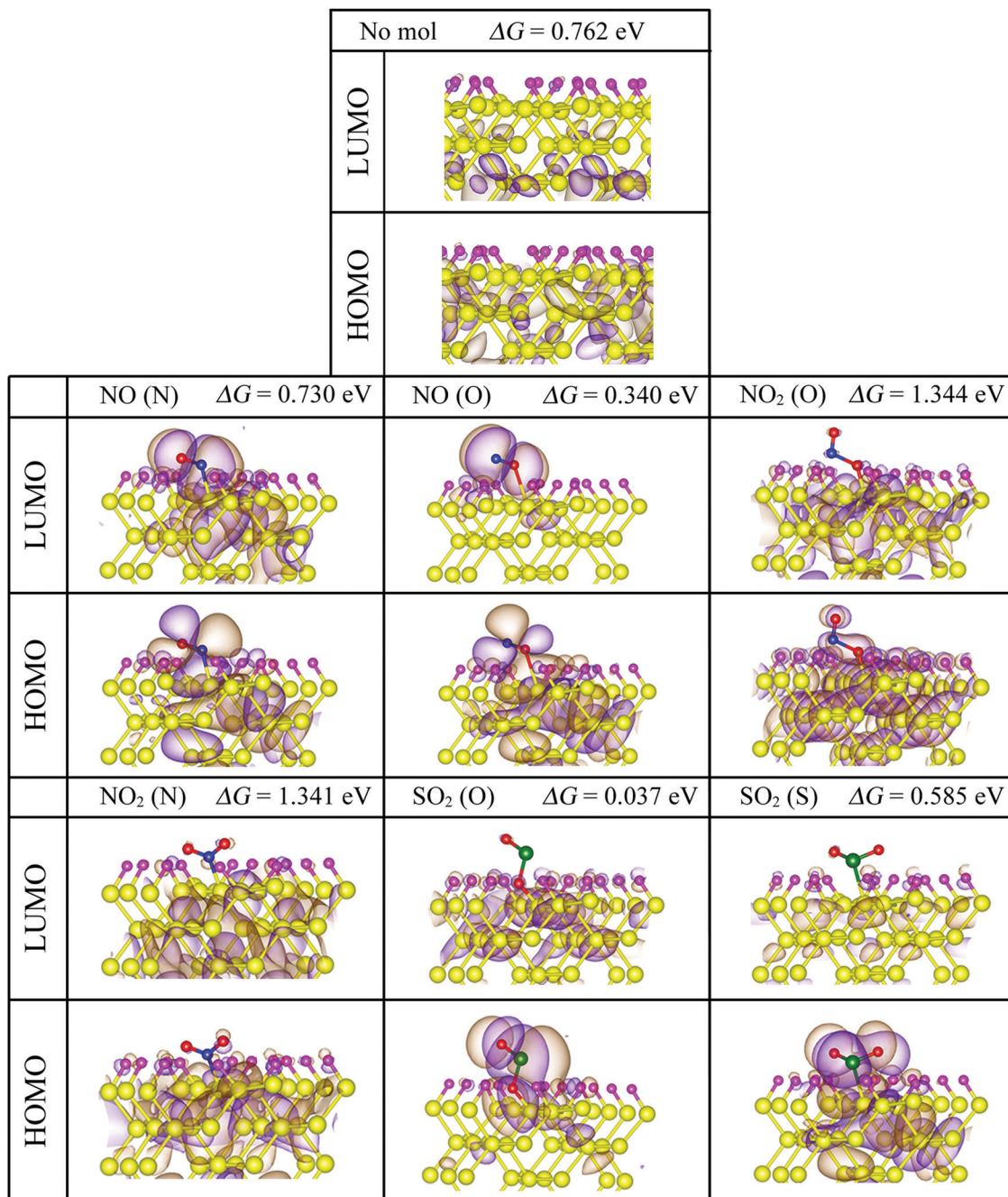


Fig. 9 Isosurfaces of HOMO and LUMO orbitals, with corresponding band gaps for all studied molecules adsorbed on F-passivated pSi. The isosurfaces have a value of 0.03 electron per Å³. Purple (brown) isosurfaces represent positive (negative) values of the plotted wavefunction on the 3D grid.

studied and compared with the hypothetical case of adsorption on hydrogen-passivated porous silicon.

We found that the molecule adsorption energies, between the toxic molecules and the pSi+F, depend on the molecule which is adsorbed on the pSi and these adsorption energies are numerically very close to the ones obtained for pSi+H, which implies that these values barely depend on the pSi passivation. In most cases, the band gap diminishes after the molecule adsorption, which can modify the conductivity of pSi facilitating the detection of different kinds of gas molecules. Especially for

SO₂ (O) case, where there is a shift of the Fermi level to the conduction band, similar to a n-type doping effect.

The NO₂ molecule has the largest adsorption energy on pSi, however, it does not significantly modify the former bandgap of the passivated pSi. Due to the large adsorption energies found for NO₂, pSi+F could be used as a chemical trap for this hazardous gas. Moreover, the results suggest that pSi+F is suitable for NO detection since the adsorption energies are slightly above 0.5 eV, which indicates that a weak chemical bond is formed, and there is also a marked reduction of the



former bandgap of pSi+F. Besides, it has the best relative stability. Also, some of these cases could be interesting for the design of optical sensors, since the optical band gap of pSi changes upon toxic molecule adsorption.

This work presents theoretical evidence of the potential applications of fluorinated pSi as chemical traps or sensors of different types of hazardous gases. We believe that this study can help to the development of future experimental and theoretical research in the fields of electronic engineering and environmental protection.

Conflicts of interest

There are no conflicts to declare.

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